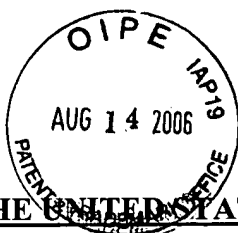


S/N 10/656,745



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Robert William Courtenay	Examiner:	Kirsten C. Jolley
Serial No.:	10/656,745	Group Art Unit:	1762
Filed:	September 05, 2003	Docket:	303.936US5
Title:	METHOD AND APPARATUS FOR COATING A WAFER		

INFORMATION DISCLOSURE STATEMENT

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 *et. seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicant respectfully requests that this Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicant requests that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicant with the next official communication.

Pursuant to 37 C.F.R. §1.97(b), it is believed that no fee or statement is required with the Information Disclosure Statement. However, if an Office Action on the merits has been mailed, the Commissioner is hereby authorized to charge the required fees to Deposit Account No. 19-0743 in order to have this Information Disclosure Statement considered.

Pursuant to 37 C.F.R. 1.98(a)(2), Applicant believes that copies of cited U.S. Patents and Published Applications, and Non-Published Applications identifiable by USPTO Serial Number, are no longer required to be provided to the Office. Notification of this change to this effect was provided in the United States Patent and Trademark Office OG Notices dated October 12, 2004 and October 19, 2004. Thus, Applicant has not included copies of any US Patents or US Patent Applications identifiable by serial number that may be cited with this submission. Should the Office require copies to be provided, Applicant respectfully requests that notice of such requirement be directed to Applicant's below-signed representative. Applicant acknowledges the requirement to submit copies of foreign patent documents and non-patent literature in accordance with 37 C.F.R. 1.98(a)(2).

The Examiner is invited to contact the Applicant's Representative at the below-listed telephone number if there are any questions regarding this communication.

Respectfully submitted,

ROBERT WILLIAM COURTENAY

By his Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
P.O. Box 2938
Minneapolis, MN 55402
(612) 349-9587

Date

9 Aug '06

By

Timothy B. Clise
Timothy B. Clise
Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 9 day of August 2006.

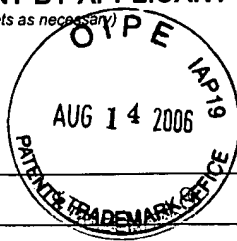
Name

Kate Garrison

Signature

Kate Garrison

Substitute for form 1449A/PTO
**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Use as many sheets as necessary)



Complete if Known

Application Number	10/656,745
Filing Date	September 5, 2003
First Named Inventor	Courtenay, Robert
Group Art Unit	1762
Examiner Name	Jolley, Kirsten

Sheet 1 of 1

Attorney Docket No: 303.936US5

US PATENT DOCUMENTS

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Filing Date If Appropriate
	US-3,793,054	02/19/1974	Franz, Helmut	07/06/1971
	US-3,876,450	04/08/1975	Tanner, W J.	08/13/1973
	US-4,340,622	07/20/1982	Kik, Leendert, et al.	11/19/1979
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	US-5,972,110	10/26/1999	Akimoto, Masami	09/02/1997

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	T ²
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OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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EXAMINER

DATE CONSIDERED

S/N 10/656,745

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Robert W. Courtenay

Examiner: Kirsten C. Jolley

Serial No.: 10/656,745

Group Art Unit: 1762

Filed: September 5, 2003

Docket: 303.936US5

Title: METHOD AND APPARATUS FOR COATING A WAFER

COMMUNICATION CONCERNING RELATED APPLICATION(S)

MS RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Applicant would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

<u>Serial/Patent No.</u>	<u>Filing Date/Issue Date</u>	<u>Attorney Docket</u>	<u>Title</u>
08/508051	July 27, 1995	303.936US1	METHOD AND APPARATUS FOR IMPROVED COATING OF A SEMICONDUCTOR WAFER
08/949072 5,902,399	October 10, 1997	303.936US2	METHOD AND APPARATUS FOR IMPROVED COATING OF A SEMICONDUCTOR WAFER
09/292081 6,423,380	April 14, 1999	303.936US3	METHOD AND APPARATUS FOR IMPROVED COATING OF A SEMICONDUCTOR WAFER
11/459426	July 24, 2006	303.936US6	METHOD AND APPARATUS FOR COATING A WAFER

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

Respectfully submitted,

ROBERT W. COURTENAY

By Applicant's Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

P.O. Box 2938

Minneapolis, MN 55402

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Date

9 Aug '06

By

Timothy B. Clise

Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 9 day of August 2006.

Name

Kate Gannon

Signature

Kate Gannon